

Title: Manufacturing Methods And Vacuum Or Hermetically Packaged Micromachined Or MEMS Devices Formed Thereby Having Substantially Vertical Feedthroughs

First Named Inventor: Khalil Najafi, et al.

Application Serial No.: / Atty. Docket No.: UOM 0281 PUSP

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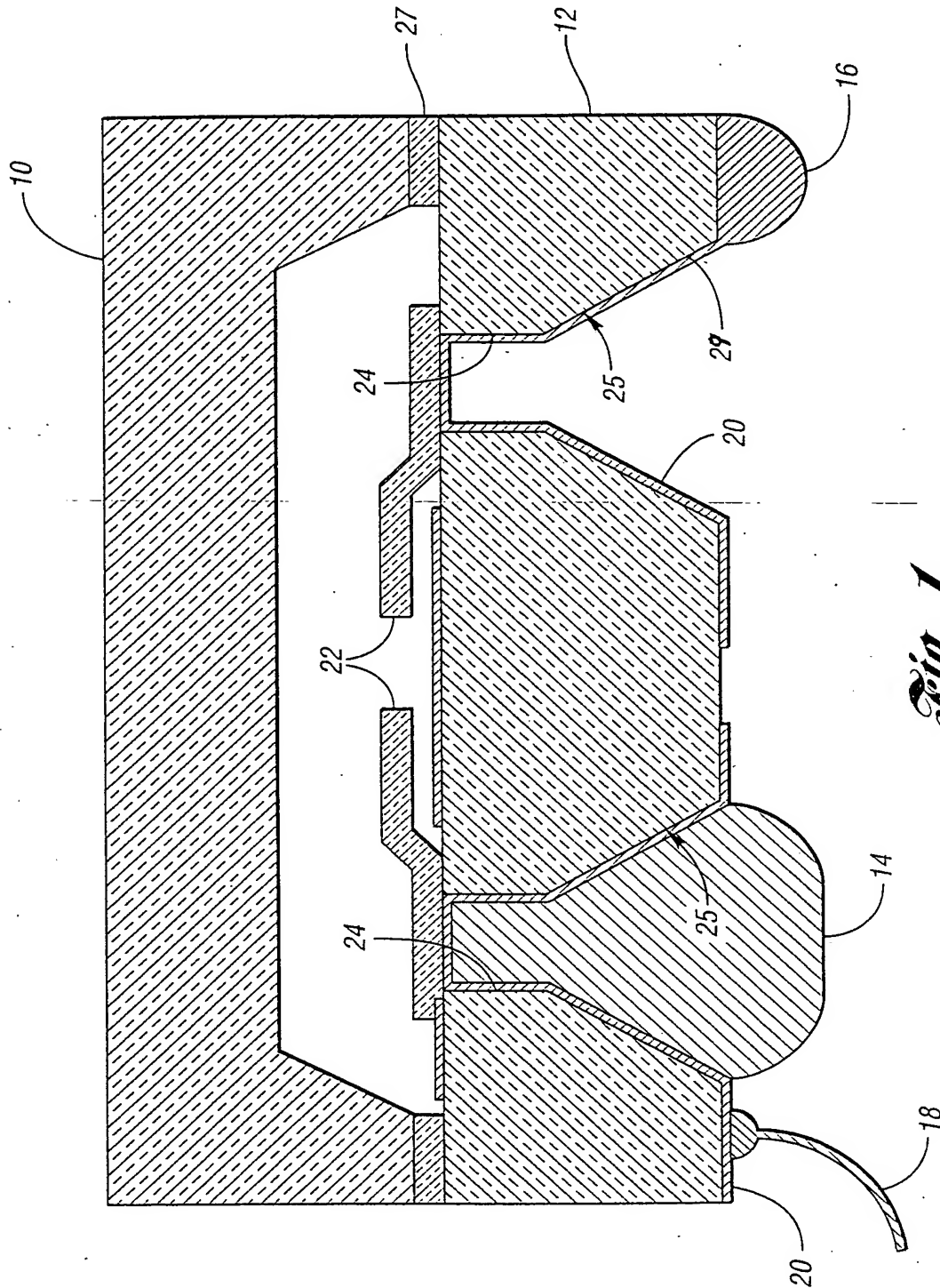


Fig. 1

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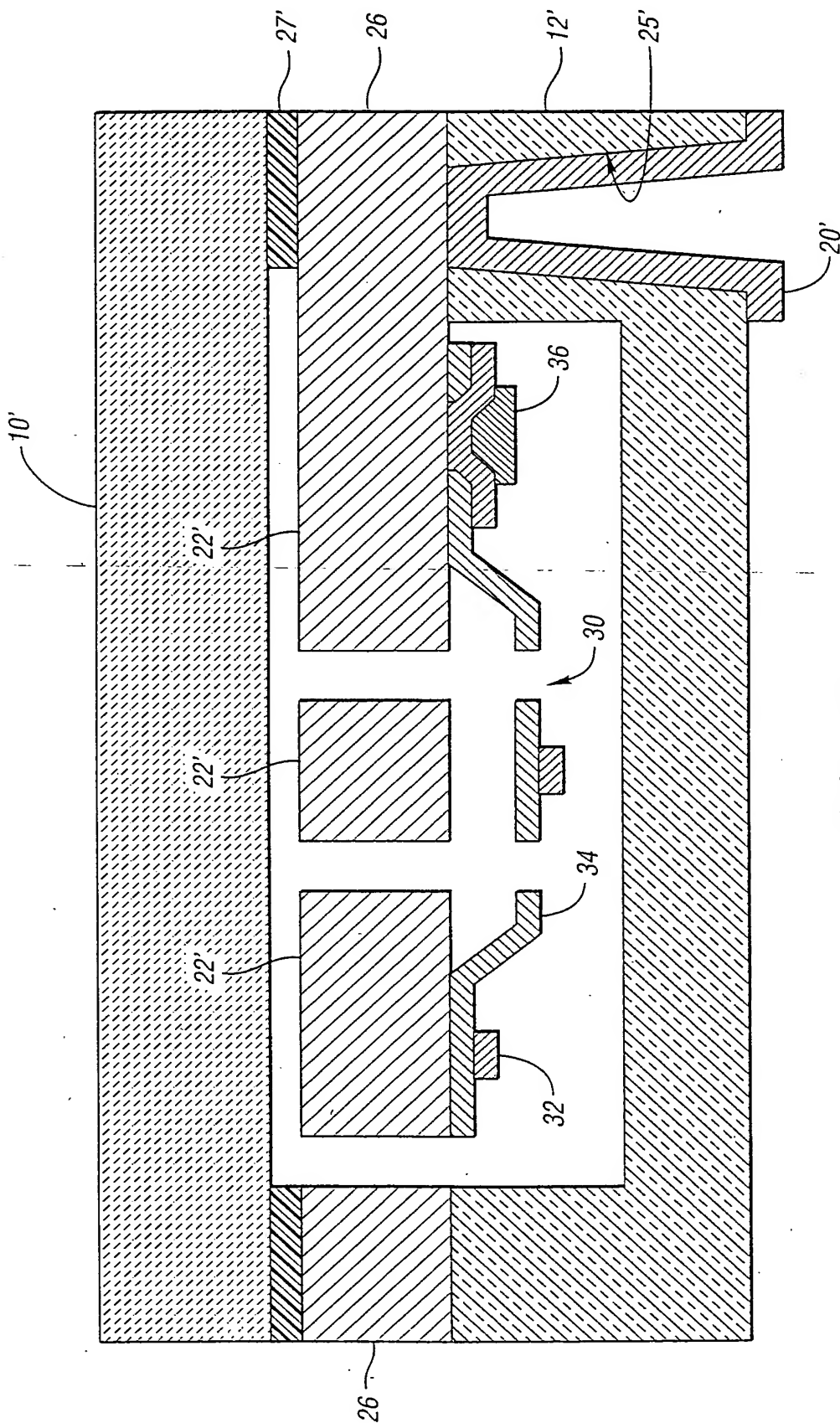


Fig. 2